

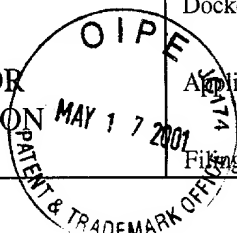
INFORMATION
DISCLOSURE
CITATION FORM FOR
PATENT APPLICATION
(FORM PTO - 1449)

Docket No.: 3536 C02

Serial No.: 09/775,295

Applicant(s): JAMES CARDUCCI, ET AL.

Filing Date: 01-31-01

Group: ~~1763~~

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Examiner's Signature:

George Gaudreau

Date Considered:

9-031

Initial if reference was considered, whether or not citation with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).

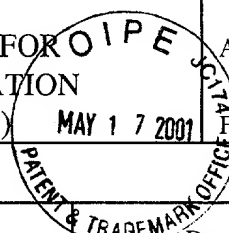
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Examiner's Signature:

George Gouldman

Date Considered:

9-031

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INFORMATION
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PATENT APPLICATION
(FORM PTO - 1449)

Docket No.: 3536 C02 Serial No.: 09/775,293

Applicant(s): JAMES CARDUCCI, ET AL.

Filing Date: 01-31-01 Group: ~~1763~~

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Examiner's Signature:

George Goudreau

Date Considered:

9-03'

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Applicant(s): JAMES CARDUCCI, ET AL.

Filing Date: 01-31-01 Group: ~~1760~~ 1763

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Examiner's Signature:

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Date Considered:

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